

In re Patent application:

SASAKI

Atty. Ref.:

035-243 N. Ha

Serial No.:

09/487,259

Group Unit:

2814

Filed:

January 19, 2000

Examiner:

A. Mai =

For:

METHOD OF MANUFACTURING SEMICONDUCTOR

DEVICE USING CHEMICAL ETCHING

January 3, 2003

Assistant Commissioner for Patents Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the United States Patent and Trademark Office the references listed on the attached form PTO-1449, a copy of each of which is enclosed. This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The references were cited in a communication dated December 3, 2002 in a corresponding European Patent Application No. 00300389.4. A copy of the December 3, 2002 communication is enclosed.

Applicant notes that the reference JP 64-73739 can be numbered as JP 01-73739 due to the change of the Imperial era name.

The Examiner is requested to initial the attached form PTO-1449 and to return a copy of the initialed document to the undersigned as an indication that the references have been considered and made of record.

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Pursuant to Rule 37 C.F.R. §1.97(c), a fee of \$180.00 as specified in Rule 17(p) is attached. If there is any shortage in the fee, please charge the deposit account of Nixon & Vanderhye, Account No. 14-1140.

Respectfully submitted,

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